

# **Notice of References Cited**

Application/Control No.

10/016,156

Applicant(s)/Patent Under  
Reexamination  
NANBA, NORIHIRO

Examiner

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Art Unit

2873

Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,668,668 A	09-1997	SHIBAYAMA et al	359/683
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	L	US-			
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## **FOREIGN PATENT DOCUMENTS**

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	N					
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## **NON-PATENT DOCUMENTS**

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6/12/03